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07/97 CP 1104
LOC-1103-1-31-98
Hester #4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Hiroshi Tayanaka

GROUP ART UNIT:

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U.S. SERIAL NO.: 08/818,239

EXAMINER:

MAR 06 1998

DATE FILED: March 14, 1997

GROUP 2500

INVENTION: "METHOD FOR MAKING THIN FILM SEMICONDUCTOR

SOLAR CELL, AND LIGHT EMITTING DIODE"

SUBMISSION OF CERTIFIED COPY OF PRIORITY DOCUMENTS

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SIR:

SEP 23 1997

Please enter of record in the file of the above application the
attached certified copy of Japanese Application No. P08-234480 filed
September 4, 1996 and P08-061552 filed March 18, 1996 and referred to
in the Declaration filed in this application. Applicant claims priority to the
March 18, 1996 and September 4, 1996 filing dates of the attached
Japanese Applications under the provisions of 35 U.S.C. Section 119.

GROUP 1100

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MAR 2 1998

Respectfully submitted,

Lewis T. Steadman (Reg. No. 17,074)
Hill, Steadman & Simpson
A Professional Corporation
85th Floor - Sears Tower
Chicago, Illinois 60606
Telephone (312) 876-0200 - Ext. 3388
ATTORNEYS FOR APPLICANT

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
the United States Postal Service as First Class Mail in an envelope
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D.C. 20231 on September 11, 1997.